

INFORMATION DISCLOSURE CITATION

Atty. Docket No. 02887.0208	Serial No. 09/920,633
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Filing Date August 3, 2001	Group: 2881

U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate	

FOREIGN PATENT DOCUMENTS							
	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No	
LN	2001-93825	4/6/01	Japan			Abstract	
LN	2000-173529	6/23/00	Japan			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
LN	D. A. Crewe, et al., <i>Initial images with a partially micromachined scanning electron microscope</i> , 14 J. VACUUM SCI. & TECH. B 3808 (Nov/Dec 1996)

Examiner <i>L. M. Nguyen</i>	Date Considered <i>12/31/2002</i>
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